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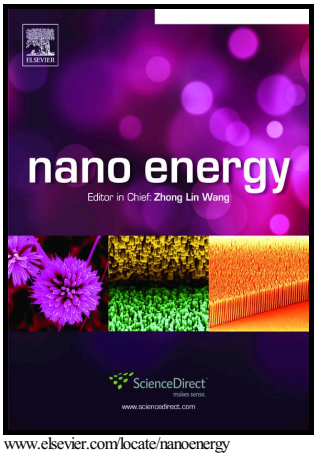

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An ultra-sensitive and rapid response speed graphene pressure sensors for electronic skin and health monitoring

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Abstract

Design of pressure sensors with ultra-sensitivity, rapid response speed and long-term stability is a key procedure to fulfill high performance electronic skins. Herein, we report the fabrication of a self-assembled 3D films platform that combines a natural viscoelastic property material P(VDF-TrFe) with an electrically conductive material rGO for the first time. Notably, modular assembly of the rGO-encapsulated P(VDF-TrFe) nanofibers led to the fabrication of a highly sensitive pizeoresistive